Form PTO 1449 (Modified)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY DOCKET NO.	SERIAL NO.							
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Par	AH	JP 5-165935	07/02/1993	JAPAN	X							
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,	АХ	Additional References sheet(s) attache										
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conformance and not considered. Include copy of this form with next communication to applicant. UNCLIENTYOSHIBAIDVDPROSECUTION24970SUS (KOP))24970S PTO 1448,000												

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